

Notic of References Cited	Application/Control No. 09/670,917		Applicant(s)/Patent Under Reexamination MIZUNO ET AL.	
	Examiner Maria Guerrero		Art Unit 2822	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,129,958	07-1992	Nagashima et al.	134/22.1
	C	US-5,874,368	02-1999	Laxman et al.	438/794
	D	US-5,868,852	02-1999	Johnson et al.	134/1.1
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Mendicino et al. "Remote Microwave Technology for Chamber Clean to Reduce PFC Emissions"; January 1998, IEEE, pages 267-276.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.